

# 3P INSTRUMENTS

## DEPARTMENT OF POROUS MATERIALS



Characterization of  
particles • powders • pores

- 0.) Altamira Company History
- 1.) What is Chemisorption
- 2.) Altamira AMI-300 family
- 3.) Altamira  $\mu$ Bench-cat and Bench-cat systems

## HISTORY OF ALTAMIRA INSTRUMENTS

- Founded in 1985 in Pittsburgh, Pennsylvania
- Pioneered automated catalyst characterization
- More than 400 instruments installed
- Global Customer base
- Recognized for excellence in customization

- AMI CATALYST CHARACTERIZATION FAMILY
- $\mu$ BenchCAT BENCH-TOP REACTOR SYSTEMS
- BENCHCAT and BenchCAT-HTS CUSTOM REACTOR SYSTEMS

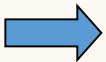
- Cooperation with 3P Instruments started in June, 2018
- OEM-supplier of the Quantachrome ChemStar until 2019
- Cooperation between Altamira and Anton Paar / QuantaTec was apparently terminated

## Physisorption

- Physisorption = Adsorption based on weak van-der-Waals-Wechselwirkungen
- Reversible
- Monolayer-/Multilayeradsorption **on the complete available surface area**

Typical systems:

N<sub>2</sub>, Ar, Kr at 77 or 87 K, CO<sub>2</sub> at 273 K



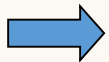
**Inert gas on the complete available surface area of the material within the sample cell**

## Physisorption

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**Inert gas on the complete available surface area of the material within the sample cell**

## Chemisorption

- Chemisorption = Adsorption by formation of a chemical bond (usually covalent) between adsorbate and adsorbent
- Irreversible
- Monolayer adsorption on the **active surface area of a catalyst**

Typical Systems:

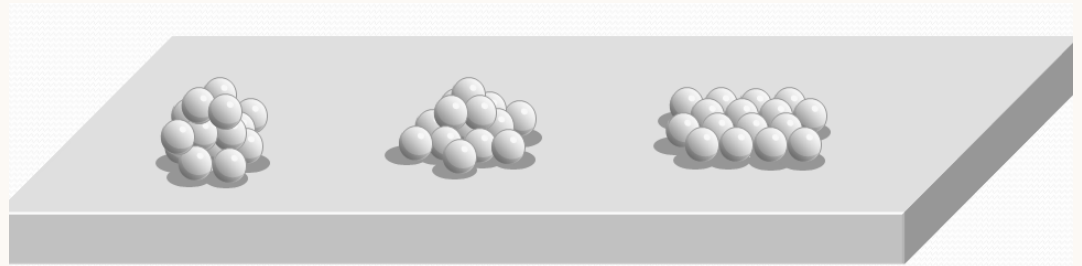
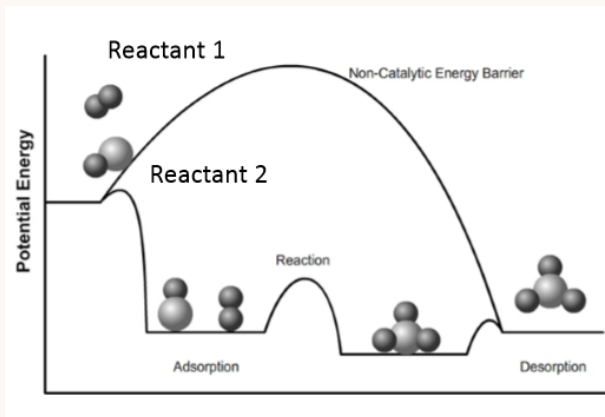
CO, H<sub>2</sub>, NH<sub>3</sub>, O<sub>2</sub>, SO<sub>2</sub> on Pt, Pd, Ni, etc...



**Reactive gases on metal centres at T > RT**

## Chemisorption to determine the active metal surface area

- The most important information of a functionalized substrate carrier is:  
**How many metal centres are available for a chemical reaction on the surface?**



- Atoms on the inside of crystallite deposits do not participate in the reaction!**
- ➔ Amount of active centres can be deduced from the chemisorbed amount of gas
- ➔ How much energy is required to produce and activate a catalyst?

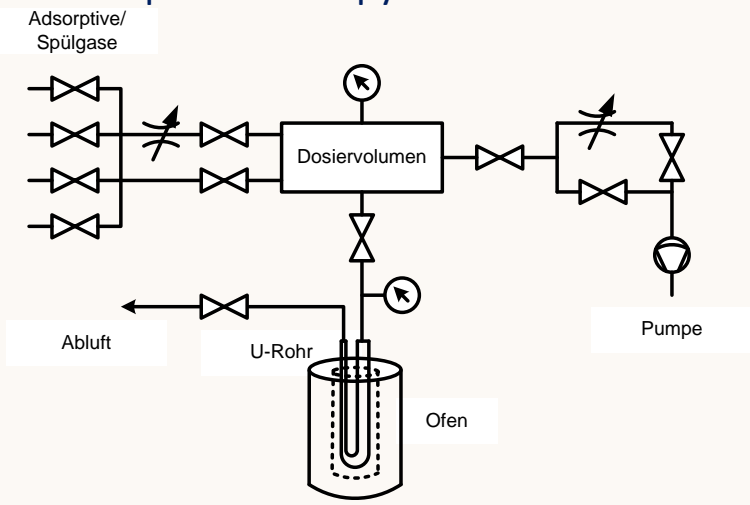


## (Vacuum) Volumetric Method

Isotherm-Analysis, comparable to physisorption measurements

Determines:

- Monolayer capacity
- Dispersion
- Crystallite size
- Adsorption enthalpy



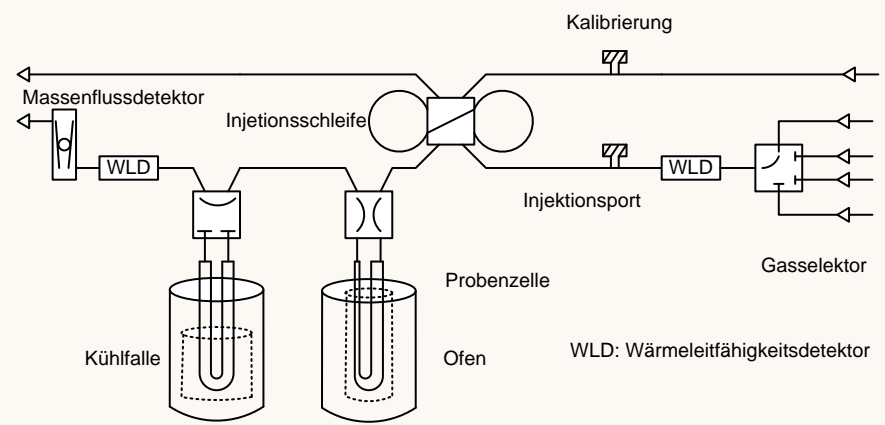
## Dynamic flow method

### Temperature Programmed Reactions **TPX**

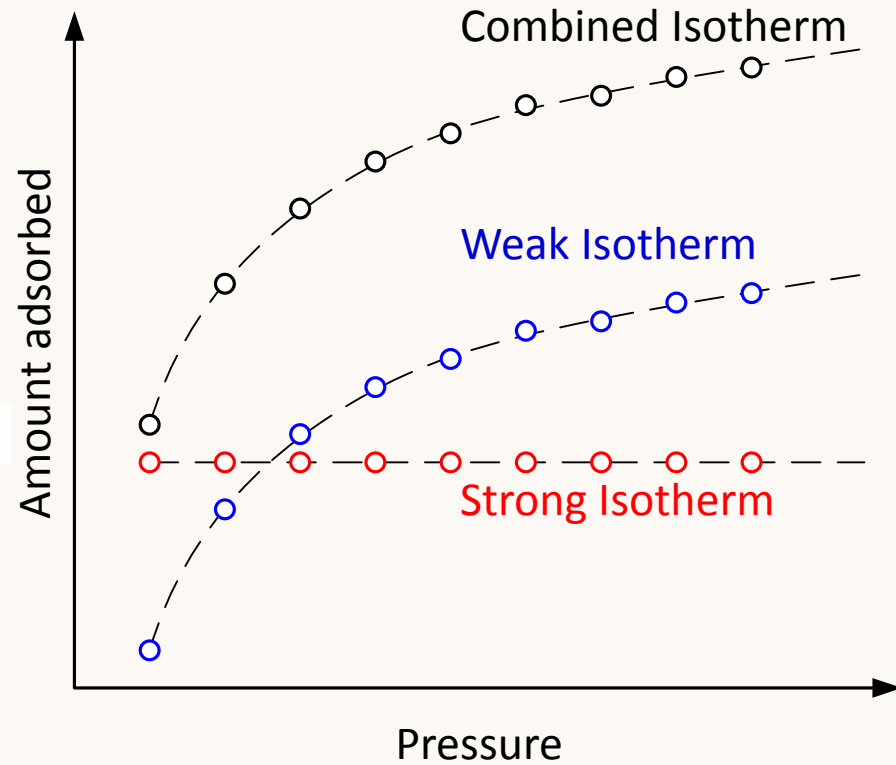
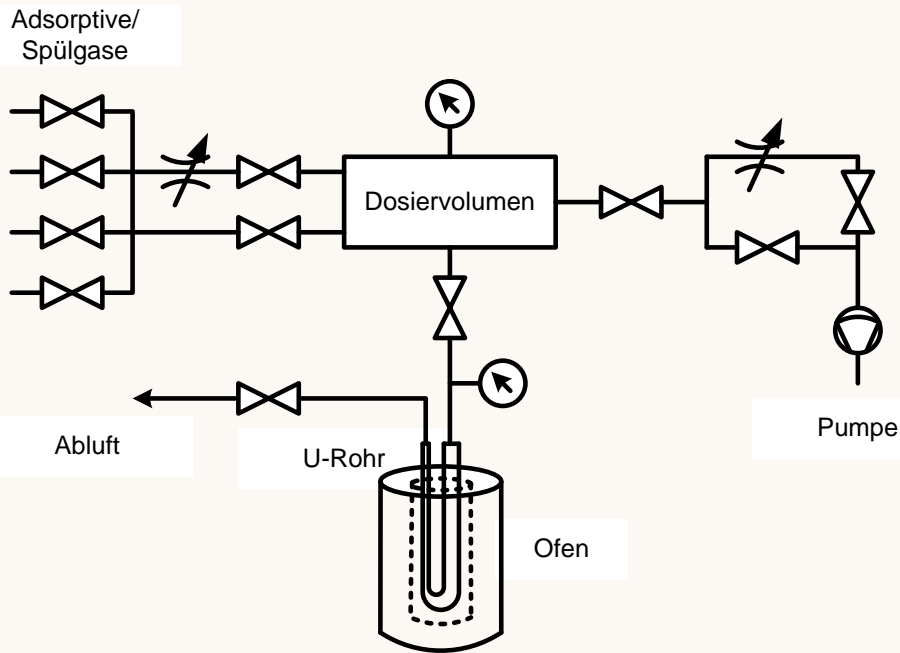
- **TPR** (TP Reduction)
- **TPO** (TP Oxidation)
- **TPD** (TP Desorption)

### Puls-Titration

Determination of monolayer capacity



# What is Chemisorption? - Methods

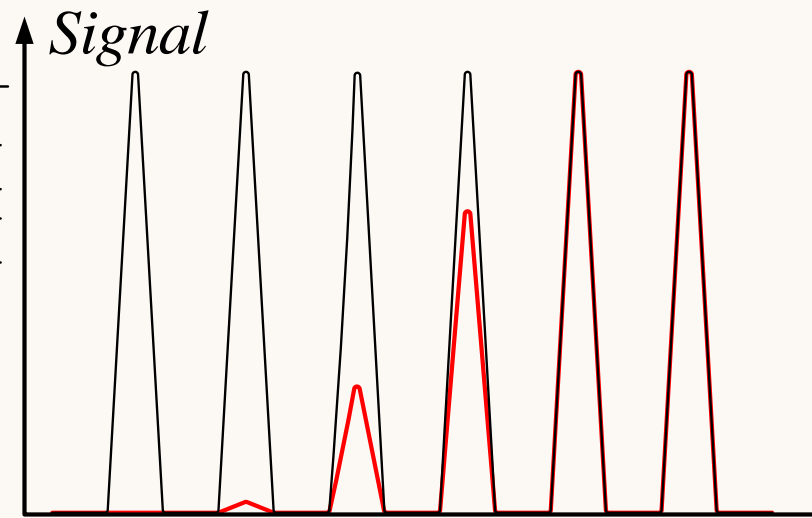
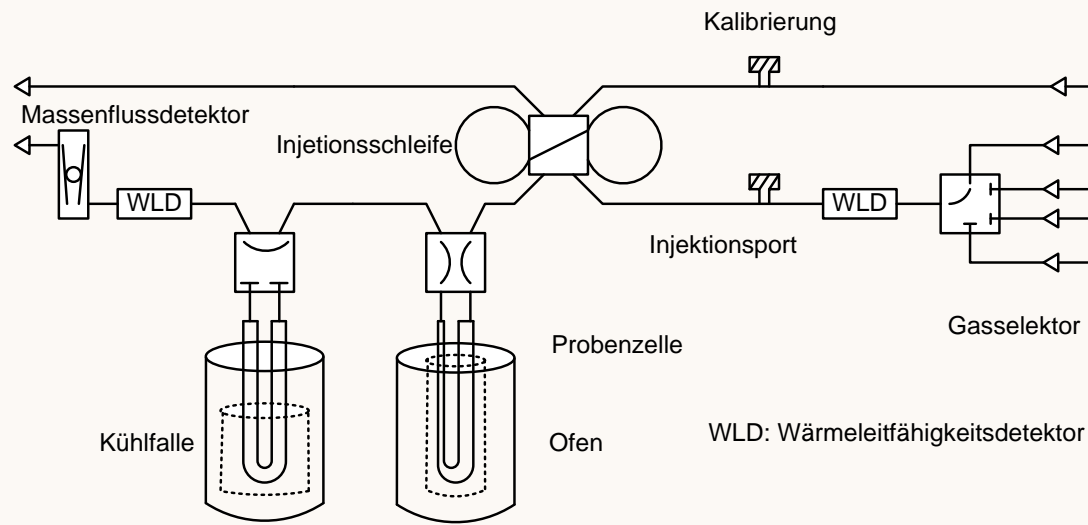


First recorded isotherm is the combined isotherm – contains both physi- and chemisorption

Second recorded isotherm is the weak isotherm – contains only physisorption

Difference between the two is the strong isotherm – contains the chemisorption information

# What is Chemisorption? - Methods

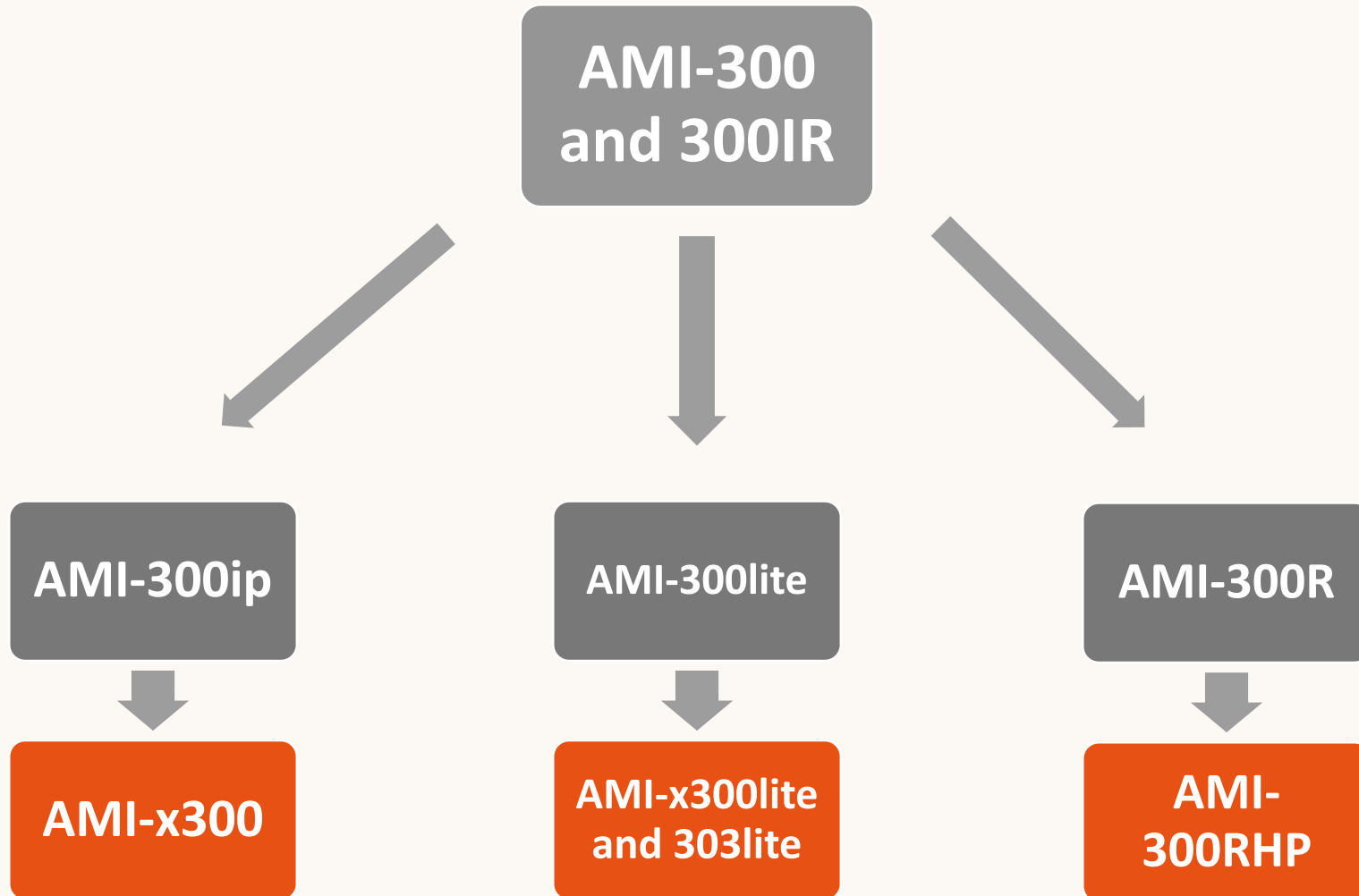


**Puls-Titration**

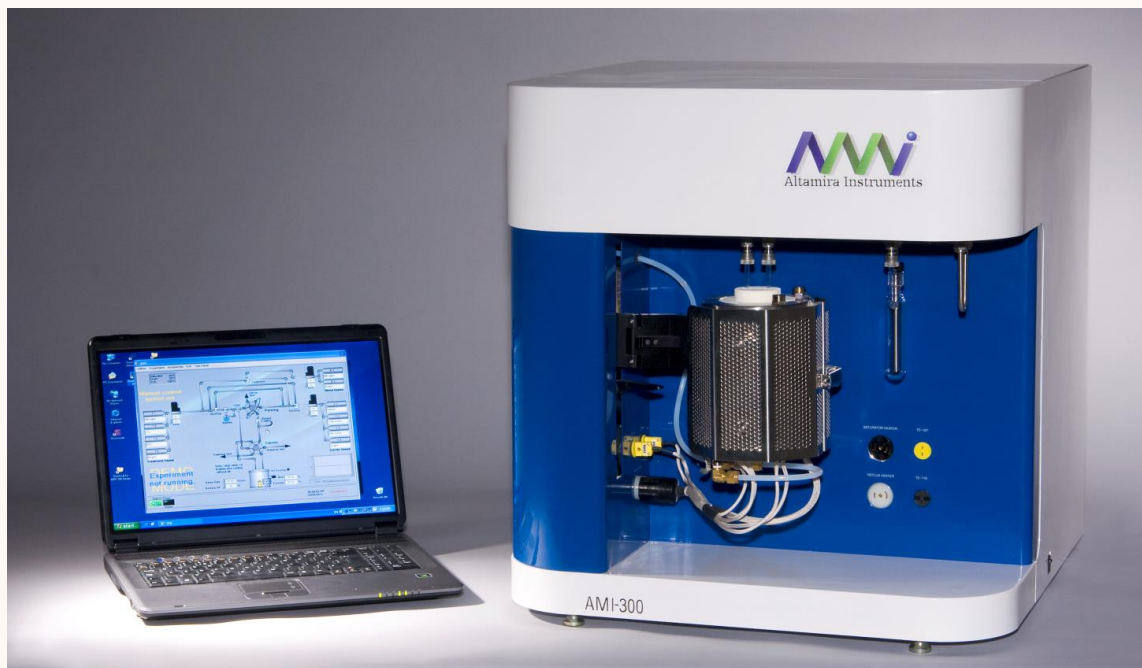
$$V_{ads} = V_1^{inj} - \left( \frac{A_1^{inj}}{A_1^{sat}} V_1^{inj} \right) + V_2^{inj} - \left( \frac{A_2^{inj}}{A_2^{sat}} V_2^{inj} \right) + \dots$$

Note, that after each pulse, weakly bound molecules will be carried away by the carrier gas, which means the adsorbed amount **corresponds to the strong adsorption from the volumetric method.**

# The AMI Characterization Family

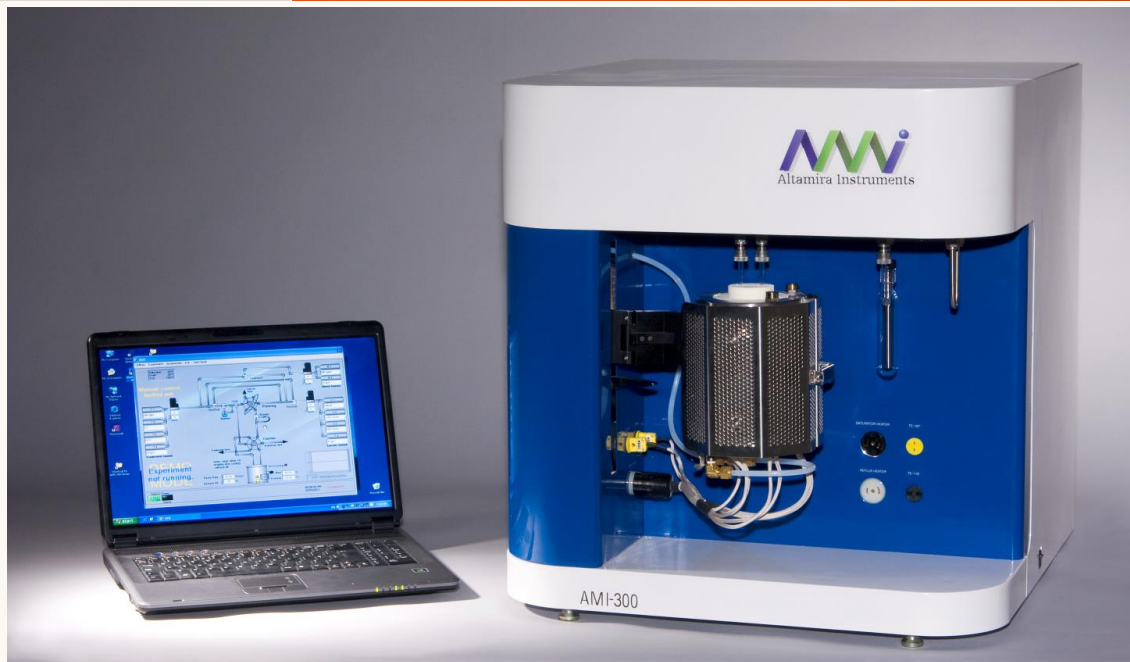


# AMI -300: THE TESTS



- TEMPERATURE PROGRAMMED REDUCTION
- TEMPERATURE PROGRAMMED OXIDATION
- TEMPERATURE PROGRAMMED DESORPTION
- ISOTHERMAL REACTIONS
- PULSE CHEMISORPTION
- DYNAMIC BET

# AMI -300: COMPONENTS



- INTERNAL TCD
- OPTIONAL SECONDARY DETECTORS (GC, MS, FID)
- HIGH TEMPERATURE FURNACE (1200C)
- GAS BLENDING INSIDE INSTRUMENT
- VAPOR SPARGING
- TEMPERATURE SAFETY SWITCH

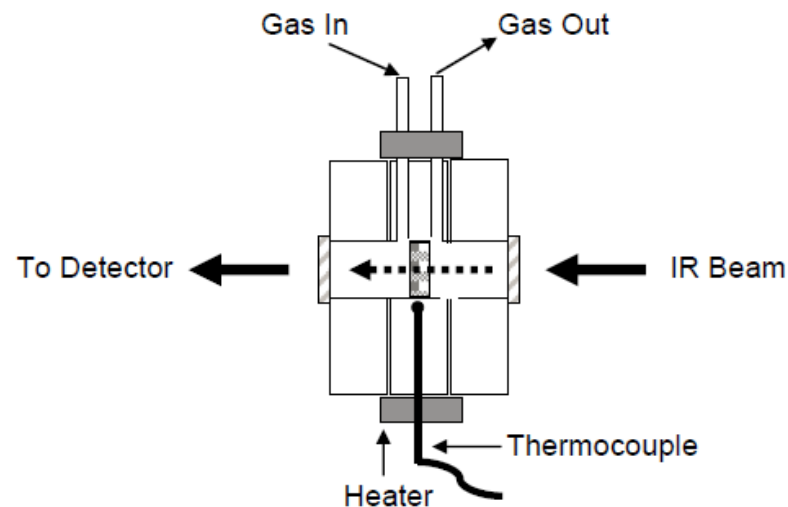
# WHY BUY AN AMI?

- **FULLY AUTOMATED**
- **SAFETY COMPONENTS**
  - Check valves on each gas inlet line
  - Hardwired TSS (redundant thermocouple)
  - Alarm Matrix for all process variables
  - Options for:
    - Gas flow stoppage if reactor breaks
    - Seismic mounts
- **MASS SPEC**
  - Can be connected at reactor or at vent
  - MS data is incorporated into the AMI data file
  - Custom fragmentation software gives gas pressures and not just mass numbers
- **CRYO-OPTION** to -130°C
- **“OPTIONS”**
  - Vapor generator is standard with the AMI
  - Analysis software is standard with the AMI

- **ANALYTICAL DEVICES**
  - MS
  - GC (AMI can trigger at customer defined intervals)
  - FID (yield total hydrocarbon amount)
  - FID with methanizer
- **EXTRA GAS BLENDING**
  - Altamira's 4<sup>th</sup> MFC is strictly for gas blending and not for TCD reference
- **CRYO-OPTION**
  - -130°C minimum
- **HARSH SERVICE APPLICATIONS**
  - High percentage sulfur compounds (H<sub>2</sub>S, SO<sub>2</sub>)
  - Halides



## AMI -300ir



- IN-SITU OBSERVATION OF ADSORBED SPECIES TO DETERMINE TYPE AND MODE OF ADSORPTION
  - TEMPERATURE PROGRAMMED OXIDATION/REDUCTION
  - TEMPERATURE PROGRAMMED DESORPTION
  - PULSE CHEMISORPTION

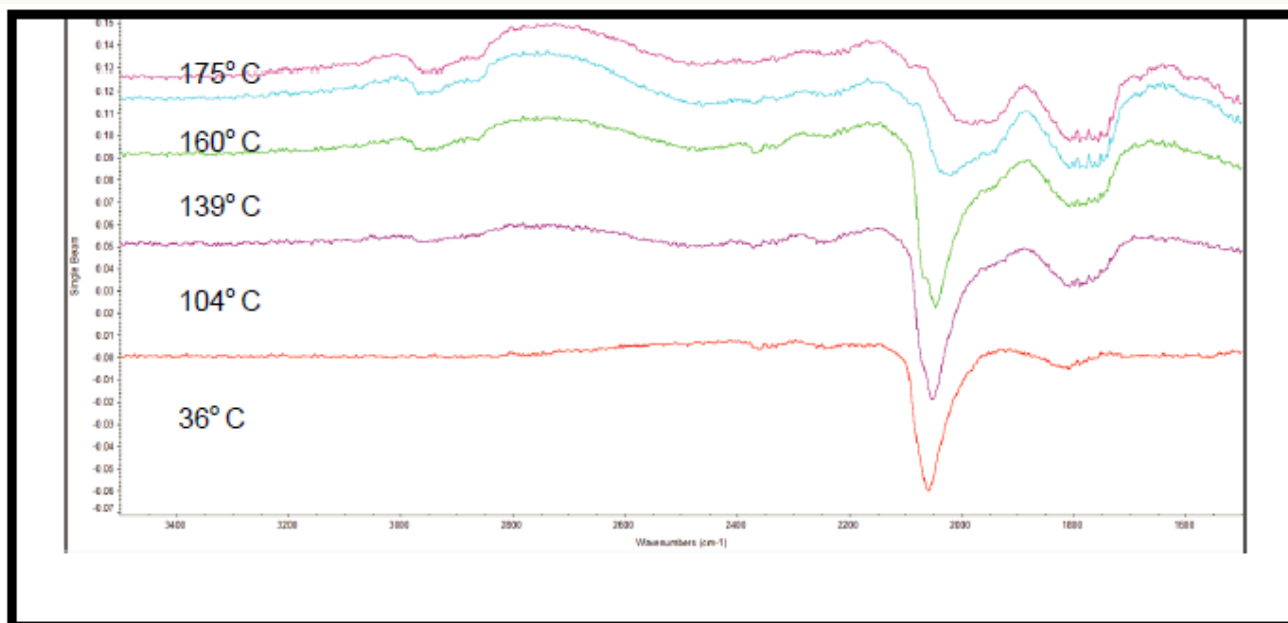


Figure 5. CO signal as a function of temperature.

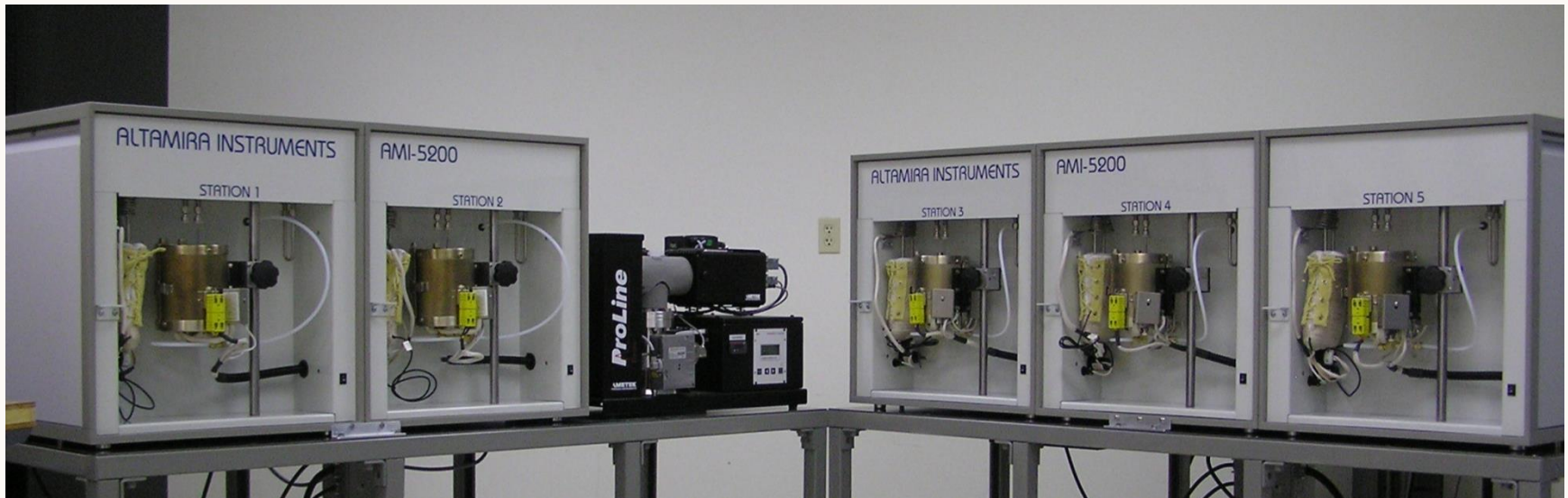
- CUSTOM TRANSMISSION CELL
  - Temperatures to 500°C (variable of inert/carrier gas)
  - May be used in conjunction with other detectors (TCD, MS)
  - Cells are also available for RAMAN or other applications (i.e. photo-catalysis)

# AMI -300ip = Higher Throughput



AMI-300ip is:

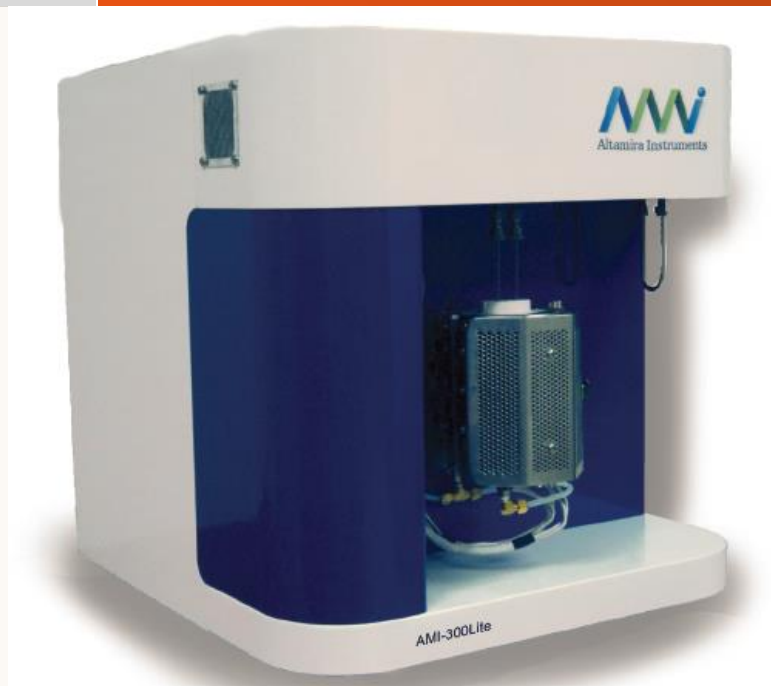
- Two Work Stations
  - 1 for Pretreatment
  - 1 for Characterization
- Switch functions automatically



## AMI-5300

- 5 times the through-put!
- Fully automated from a single PC
- Each station is fully independent
- Multi-port Mass spectrometer allows for queue of stations and sampling
- X300 gives you the option to have as many stations as you want

# AMI – 300lite



- “Economy” version but can perform TPR, TPO, TPD, Pulse Chem and a single point BET
- The only fully automated “lite” instrument in the industry
- Optional pre-treatment station at the same time as TPR/TPO/TPD/Pulse Chemisorptions!
- Optional multi-station available for higher throughput!

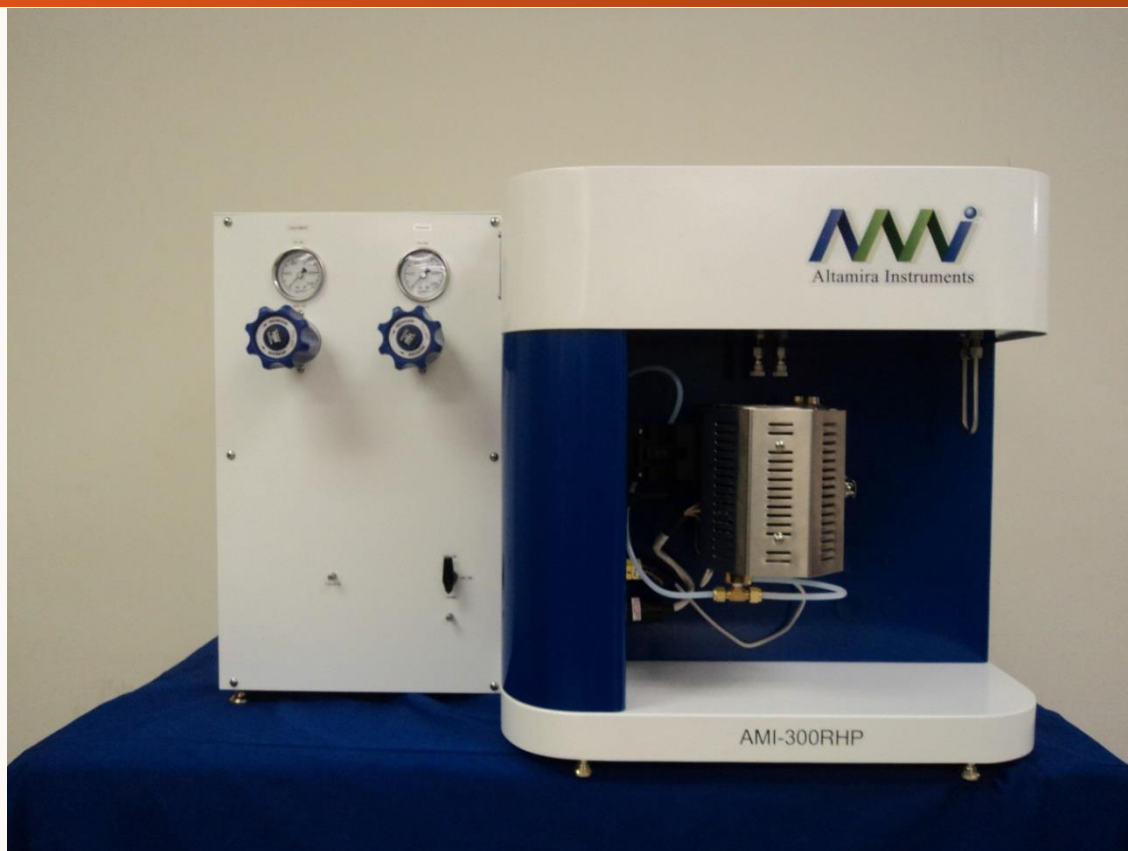
# The New AMI – 303lite



- Run 3 samples at one time!
- 3 TCDs, 3 reactors (in one furnace), 3 MFCs (one per station)
- TPR, TPO, TPD, Pulse Chemisorption



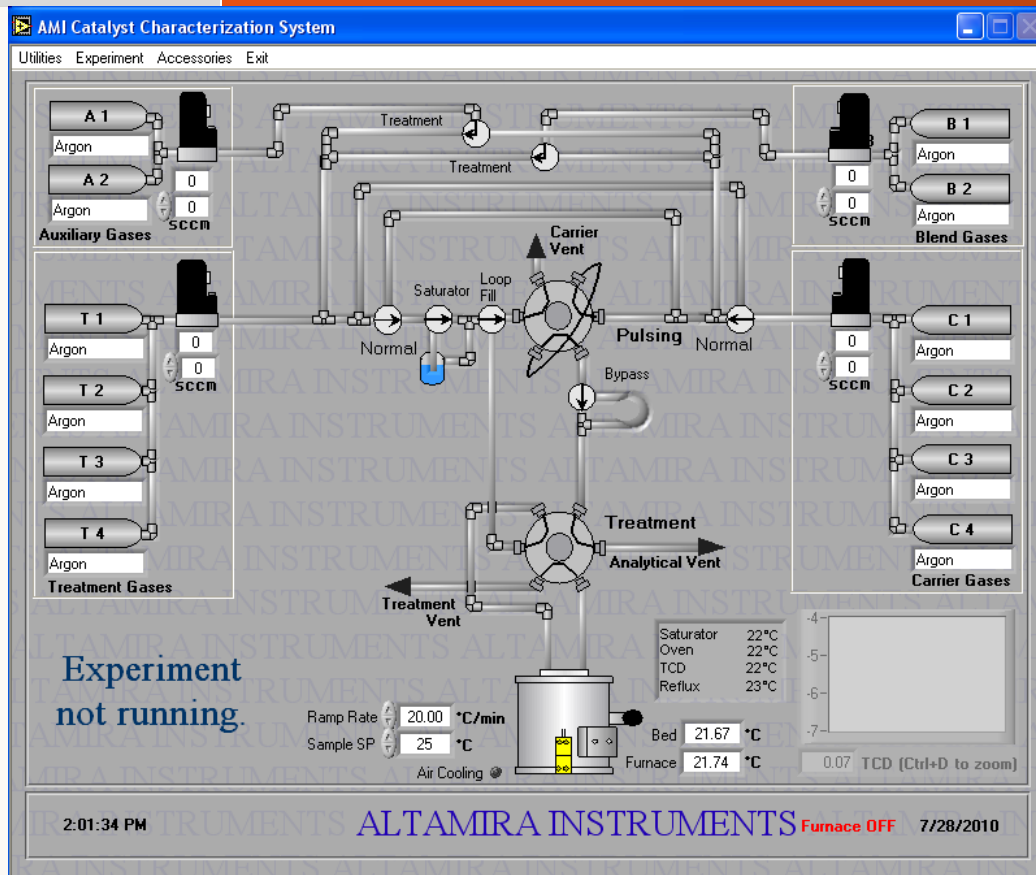
## AMI - 300 RHP



## AMI-300 RHP

- R = pump; HP = high pressure
- Liquid pump
- High pressure reaction experiments (two in one: micro-reactor AND chemisorption)
- High Pressure characterization (to 100 bar)
- Auxiliary Detection Valve(s) for reaction experiments to external device
- Automatic pressure regulation

# AMI 300 SOFTWARE



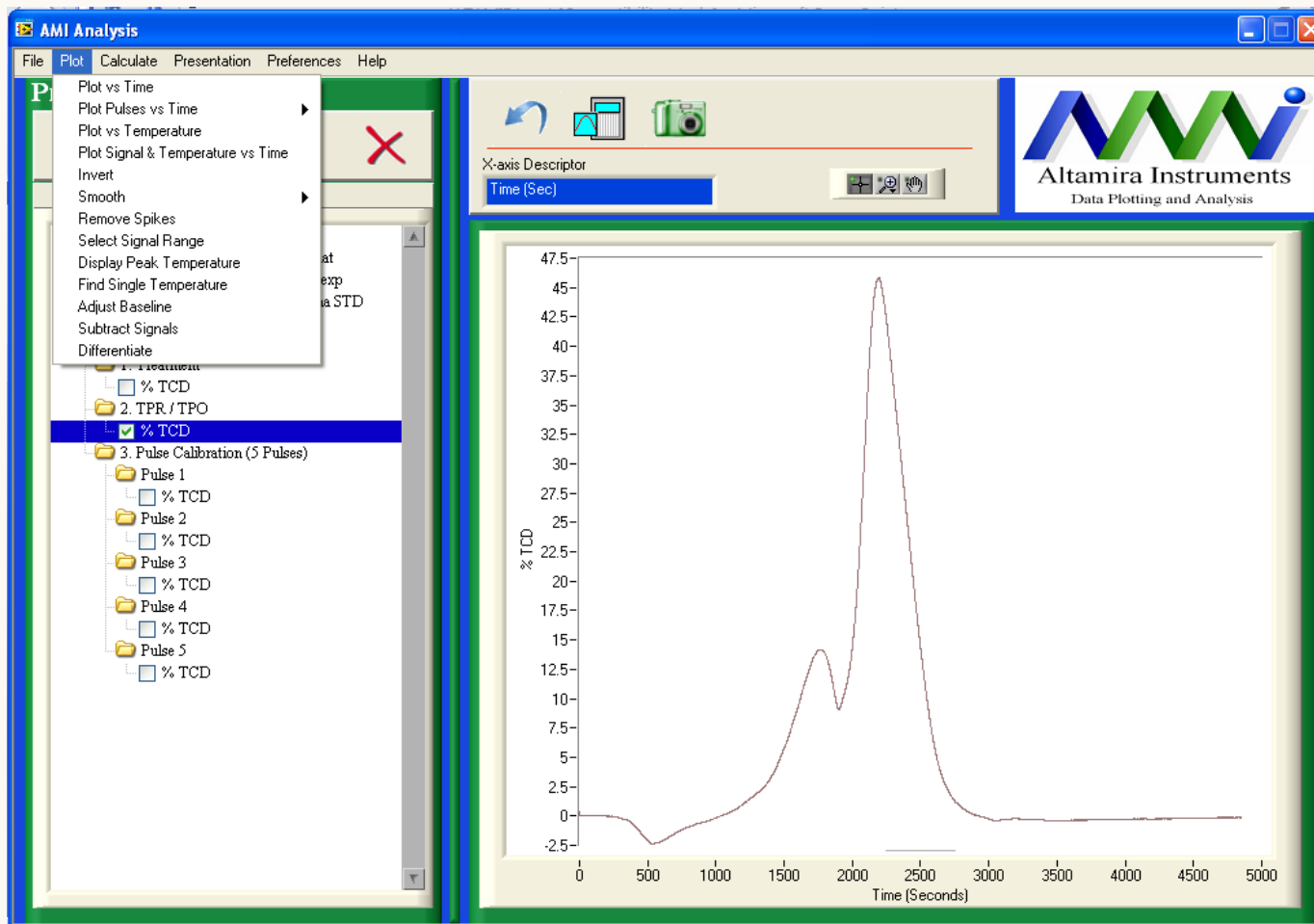
- Software operates on Windows platform via LabVIEW
- Fully Automated designed for unattended operation
- User Friendly experimental setup and control via P&ID-like screen
- Control and/or trigger MS, GC, FID, etc...



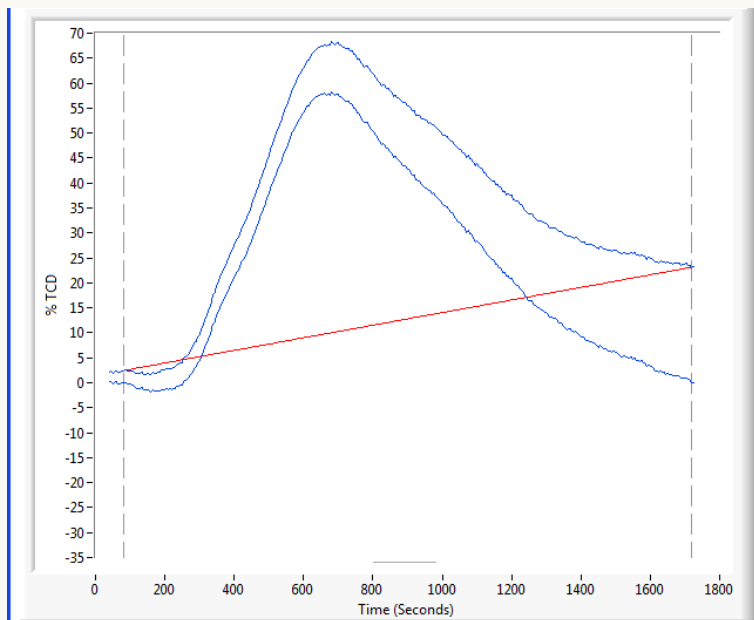
# DEFINING PARAMETERS FOR PROCEDURES

Detector	Bypass TCD? Y/N.....	<input type="checkbox"/> No
	Delay for Auto Baseline? Y/N.....	<input type="checkbox"/> Yes
	TCD Current, 50-200 mA.....	75 mA
	TCD Gain, 1-100.....	2
Starting Conditions	Signal Sample Rate, 0.5-100 sec/pt.....	50.0 sec/pt
	Carrier Gas .....	10% H2/Ar
	Flow Rate, 5-50 cc/min .....	30 cc/min
	Initial Temperature, -100 -1200 degC .....	25 degC (OFF)
	Hold Time, 0-999 min .....	10 min
Blend Conditions	Blend Gases? Y/N.....	<input type="checkbox"/> No
	MFC-3 Gas.....	No Gas Selected
	Flow Rate, 5-50 cc/min.....	0 cc/min
	Treatment Gas .....	No Gas Selected
	Flow Rate, 5-50 cc/min .....	0
Ramp & Hold	End Temperature, -100 -1200 degC.....	550 degC
	Ramp Rate, 1-30 degC/min.....	10.00 degC/min
	Hold Time, 0-999 min.....	30 min
Postflush	Flow Rate, 5-50 cc/min .....	30 cc/min
	Hold Time, 0-999 min.....	2 min

5:20 PM
TPR/TPO
2/14/02

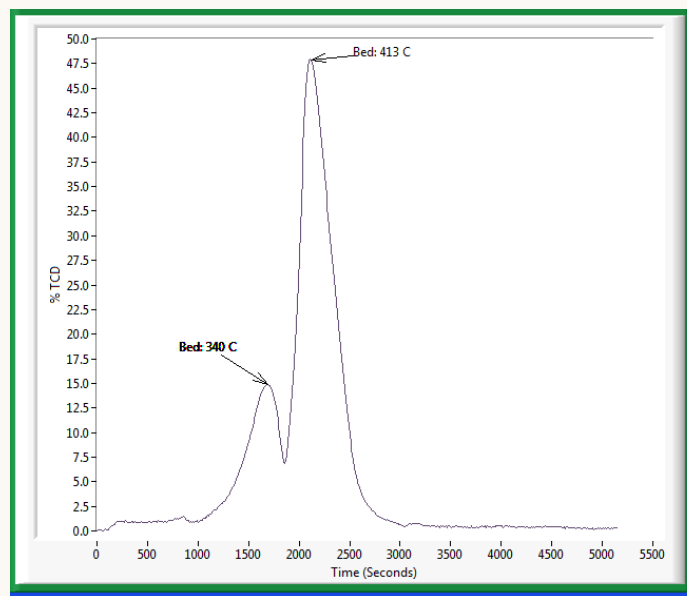


# ADJUST BASELINE AND DISPLAY PEAK TEMPERATURES



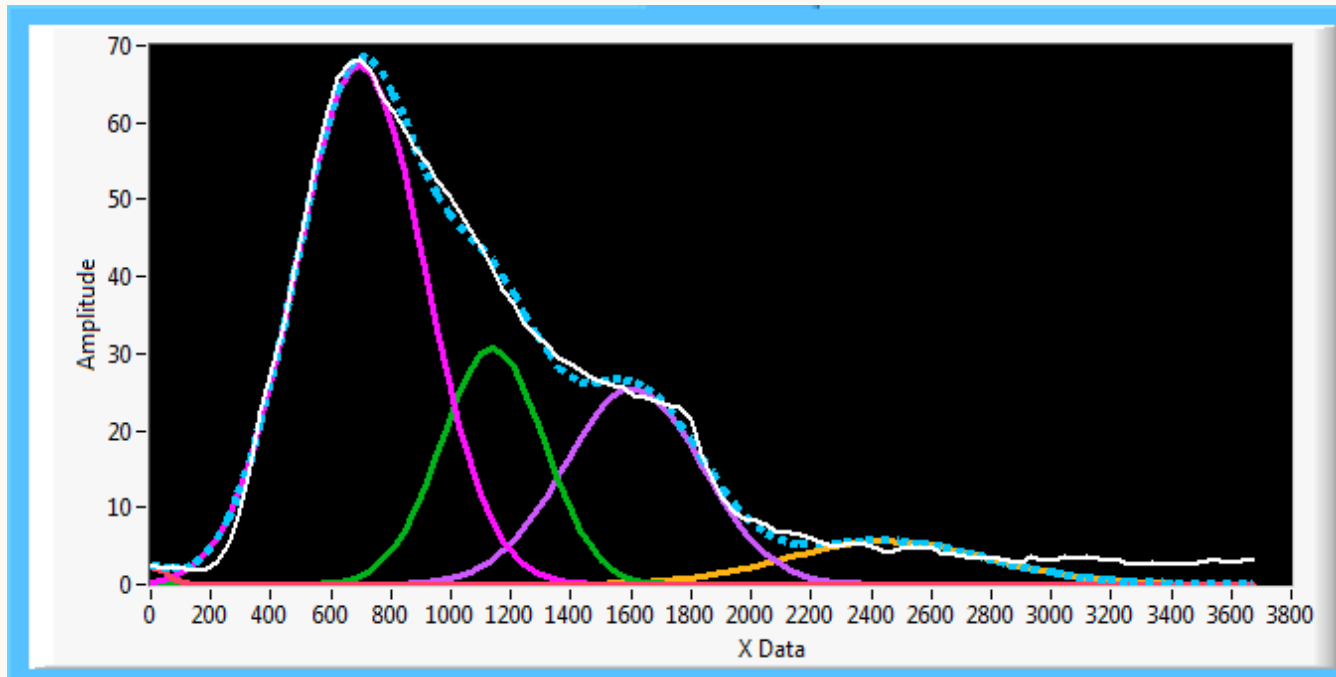
- Adjust your baseline automatically by a simple click and drag!

- Locate peak temperatures with a simple click of the mouse.



## Peakfit of a TPD

- Gaussian fit of a 64% Ni/SiO<sub>2</sub> TPD
- $R^2 = .9934$



- How do the results between static and dynamic chemisorption processes compare?
- What kind of samples are suitable for testing?
  - Supported metal catalyst
  - Acid catalysts
  - Oxidation catalysts
  - Even some samples for gas-sorption measurements
- Spec-manship/Performance specifications?



## μBenchCAT

- Fully automated *standardized* bench-top reactor for catalytic studies.
- Gas or liquid phase possibilities
- Standard options for pumps, pressures, and material

## μBenchCAT

- Up to 6 gases
- Up to 2 liquids
- 650C to 1200C depending upon reactor material
- Heated oven to 200C for liquid/gas preheating and vaporizations
- Hardware, Firmware, and Software safety measures
- Connection to external analytical devices

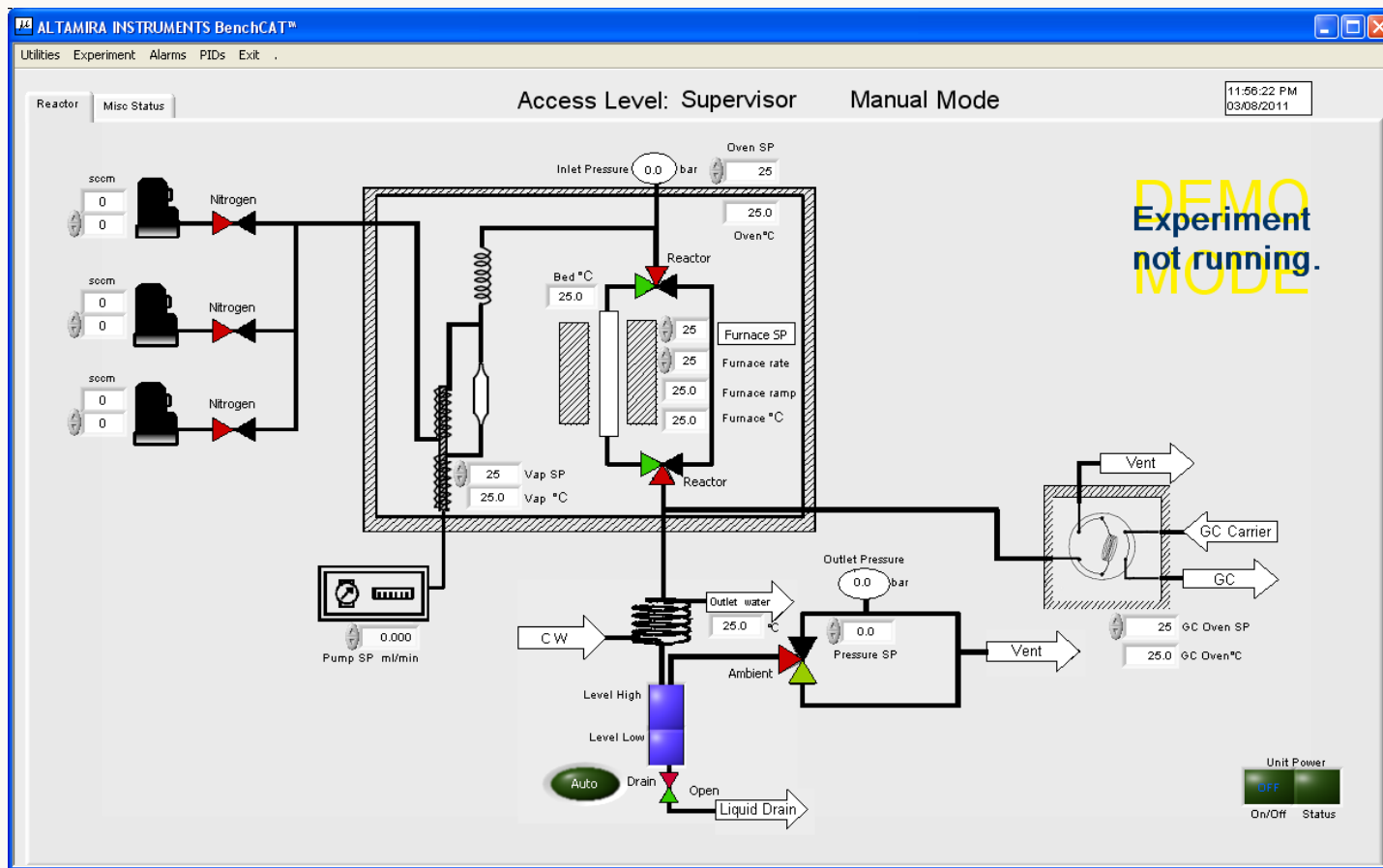


# WHY BUY a $\mu$ BENCHCAT

- **SAFETY COMPONENTS**
  - Check valves on each gas inlet line
  - Hardwired TSS (redundant thermocouple)
  - Alarm Matrix for all process variables
  - Flow Safety (automatic positive shut-off valves)
  - Pressure Relief Valve(s) built in
  - PLC Alarms
  - Multiple User Profiles
- **FUNCTIONALITY**
  - MFCs are set once with an inlet pressure, no “ramp-up”
  - Every component is fused
  - Open frame design
  - Optional vaporizer design with carrier gas or atomizer
- **CHEMISORPTION MODULE (external detector)**
- **PHOTO-CATALYSIS and RAMAN MODULE**
- **DUAL STATION MODULE (series/parallel)**



# μBENCHCAT REACTOR SYSTEMS



μBenchCAT

- Valve positions, flow rates, temperatures, pressures, and product sampling are all automated
- Experiments are easily written in minutes

# COMMON QUESTIONS: $\mu$ BENCHCAT

- Can a  $\mu$ BenchCAT be adapted to perform spectroscopic measurements?
- Can a system run in series or parallel mode?

## BenchCAT

Fully automated *customized* reactor, for example:

- Diesel Catalyst Studies
- Fuel Cell Catalytic Membrane Studies
- Fisher Tropsch Studies
- Gasification
- Hydrocarbon Dehydrogenation Studies
- Reactions Studies of Acetic Acid



# Application: Study of Reactions involving Membranes for Fuel Cells



- Custom designed stainless and quartz reactor for various temperatures and pressures
- Analysis performed upstream and downstream of membrane





- Liquid pressures to 350 bar
- Level Control for liquid collection

# Application: Studies of Hydrocarbon Hydrogenation



- Pressures to 100 bar and temperatures to 800°C
- Multiple detectors: FID, GC
- 4 station instrument



- Four station instrument with sampling valve to MS that allows for station queues.
- Added lexan covers for safety





- Fluid Bed Reactor
- Wet Test Meter for mass balance calculations





- Six-station plug-flow reactor in 1 oven
- Liquid sampling system with level control

# Application: Oxidation Reactions



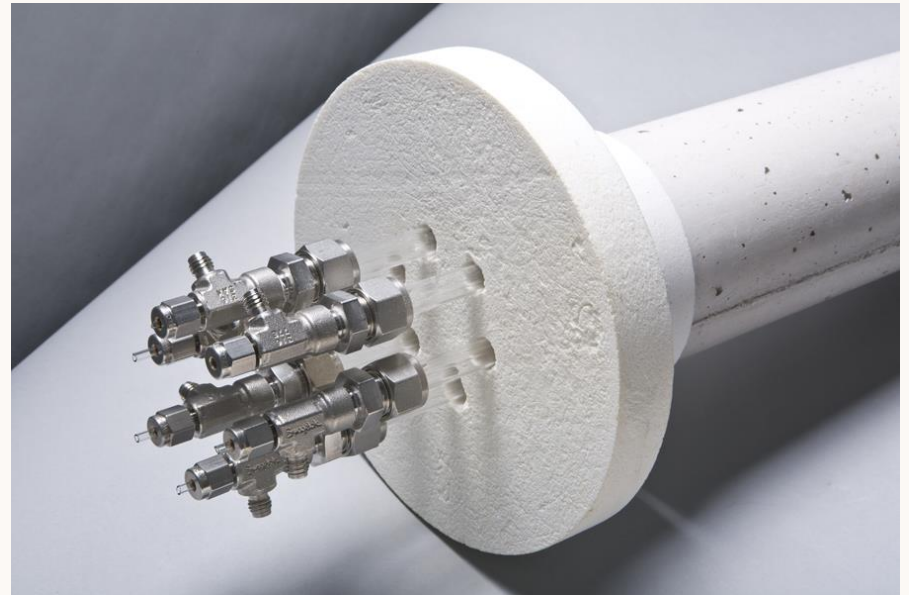
- 6 Stations in a single furnace
- Separate Electrical Cabinet



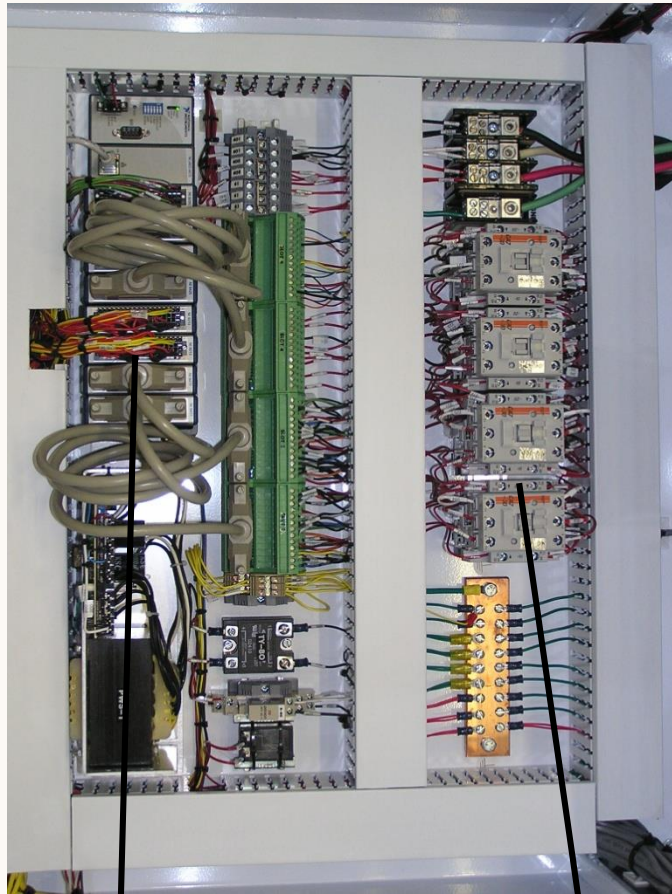
- Slip-stream sampling to MS
- 20 bar inlet charged to 100 bar before reactor with compressor
- Recycle loop with purge



# Quartz Reactors in a Single Furnace

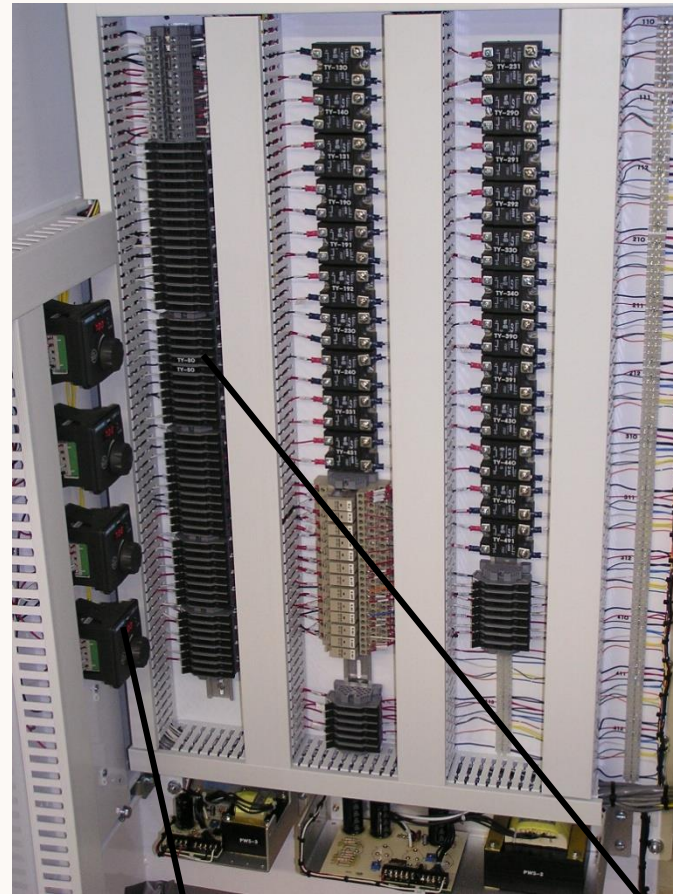


# Inside the Electrical Cabinet



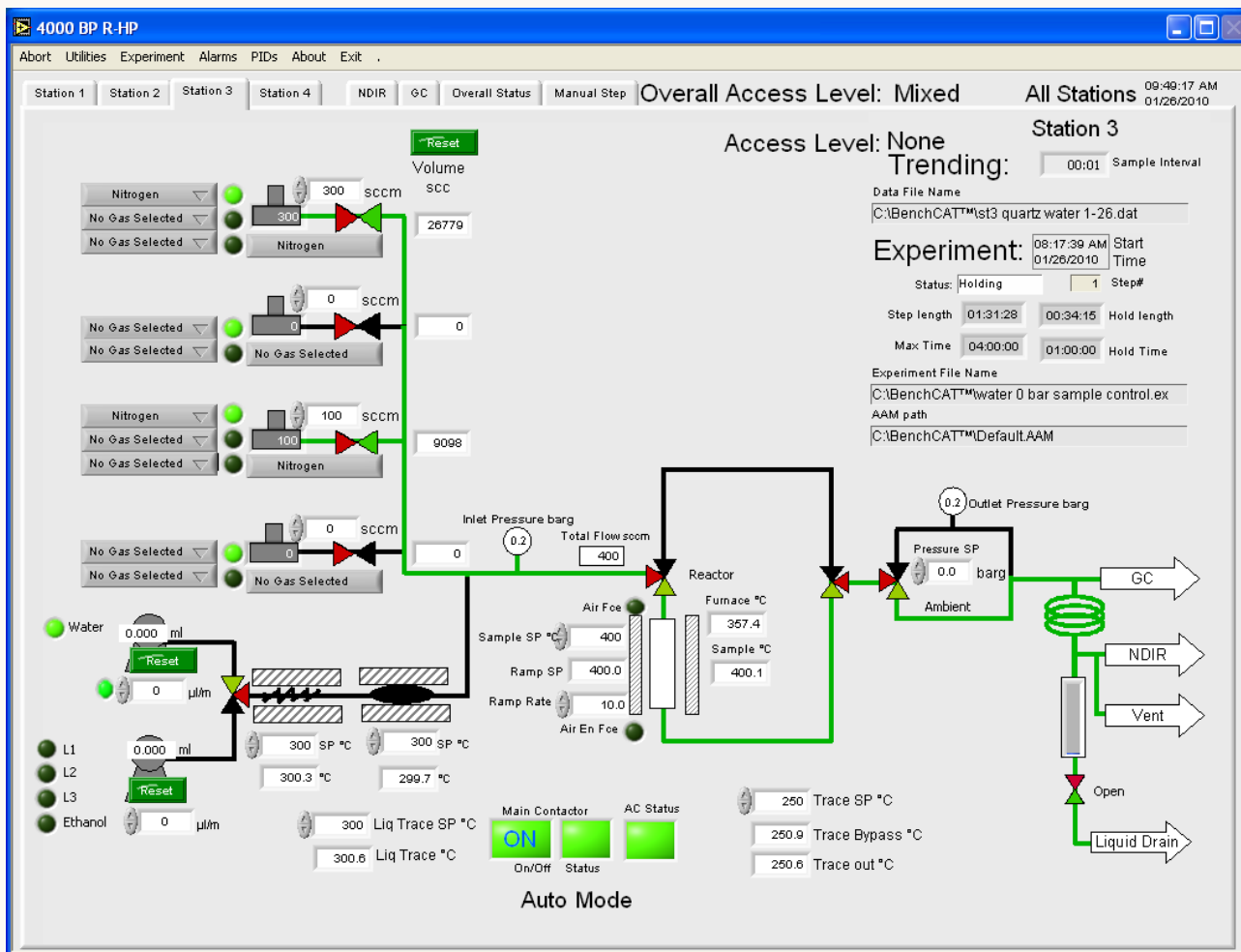
Data Sampling up to 50 Hz

Independent power to all stations



Temperature Safety Switches

Fusing on all heaters and circuits



**Define an Experiment** [X]

Files Step Close

---

**Define Steps of Experiment** CurrentStep: 5 of 5 11:35:27 AM  
01/26/2010

File path: C:\BenchCAT™\water 0 bar furnace control.ex

ExecuteStep LoadStep **All Stations**

Gas 1	0 (sccm)	Nitrogen	Reactor	Air Enabled
Gas 2	0 (sccm)	No Gas	Furnace SP	Ramp Rate
Gas 3	0 (sccm)	Nitrogen	20 °C	10.0
Gas 4	0 (sccm)	No Gas	0.0	Pressure SP barg
Pump 1	0 (µl/m)	None	20	Vap SP °C
Pump 2	0 (µl/m)	None	20	Vol SP °C
<input type="checkbox"/> Schedule GC			20	Liq Trace SP °C
Quant	0 (sccm)	Nitrogen	20	Trace SP °C
GC mode	Sample	Step mode	Manual	<input type="checkbox"/> Schedule NDIR
		Trigger	00:00:06	00:00:05 Flush Interval
		Fill	00:01:00	00:00:05 Sample Interval

Hold Time	Next Step	Max Time	Max Step	Sample Interval
00:02:00	1	04:00:00	1	00:01

AAM Path C:\BenchCAT™\Default.AAM

# COMMON QUESTIONS FOR A BENCHCAT CUSTOMER

- What are the temperature and pressure conditions?
- What is the catalyst loading?
- How many and what type of gases?
- How many and what type of liquids?
- Number of stations?
- Are there any physical size requirements?
- What external analytical devices do you need?
- What is the mode of the reactor?
  - PFR
  - CSTR
  - Trickle-bed





Characterization of  
particles • powders • pores

# 3P INSTRUMENTS

DEPARTMENT OF POROUS MATERIALS

THANK YOU!



Characterization of  
particles • powders • pores



Characterization of  

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particles • powders • pores